Advanced Integrated Circuit Design Lab



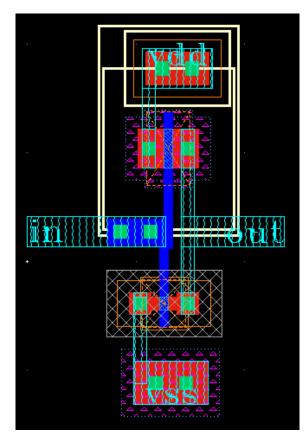
Analog Layout Introduction



General Information on Layout



- Definition: "Layout is the representation of an integrated circuit in terms of planar geometric shapes, which correspond to the patterns of metal, oxide, or semiconductor layers that make up the components of the integrated circuit." (source: Wikipedia)
- As a layout designer, the integrated circuit is viewed from the top (see on the right).
 - Different layers (well, active, poly, metal, via, ...)
 are indicated by different colors.
 - The background (black color) marks the layer of the global substrate.
 - The thicknesses of the layers are fixed by the semiconductor foundry.



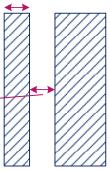
CMOS inverter layout in *umc65ll* technology



Design Rules & Physical Verification



- The layout <u>has to be</u> designed according to specific design rules, which are fixed by the foundry for each technology.
- The purpose of design rules is as follows:
 - Warranty of dimensional precision in micro fabrication
 - Warranty of precision on electrical characteristics
 - Prevention of latch-up triggered by parasitic bipolar-transistors
- Exemplary design rule violations:
 - Width of a metal interconnect too small
 - Distance between metal interconnects too small
- Physical Verification steps:
 - Design Rule Check (DRC) → Design rule violations are automatically detected and reported
 - Layout Versus Schematic (LVS) → Equivalence of layout and schematic



e.g. metal 1

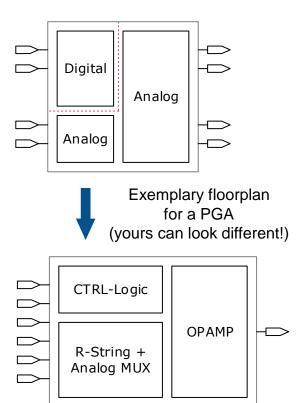
Layout Steps



Floorplanning:

- Division of the entire die area among major functional sub-blocks to facilitate interconnection and effectively utilize the available area.
 - Digital blocks* (e.g. CTRL-Logic)
 - Analog blocks (e.g. OPAMP, R-String, MUX)
- Some of the aspects to be considered:
 - Power supply nets/grid
 - I/O signal pins
 - Sizes of transistors and passives
 - Shielding/guarding*

*Shielding or guarding is a common practice in analog layout. The clock signal of any digital blocks could for example add unwanted noise to analog blocks, which might require shielding or guarding techniques! More information can be found in "The Art of Analog Layout", by Hastings.



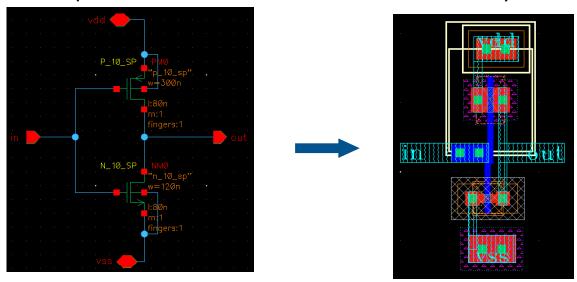


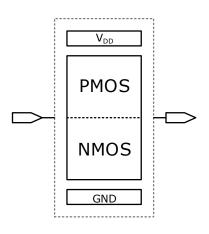
Layout Steps



Placement:

- Placing the instances/sub-blocks in the layout
- Layout design can be "schematic-driven"
 - Layout oriented towards or "following" the schematics
 - Example: Schematic-driven CMOS inverter layout





Attention: You are free to design the layout as you choose! This means your layout does not necessarily have to be "schematic-driven". Another style can be better suited for your design and might lead to a more compact and robust layout. It is your decision!

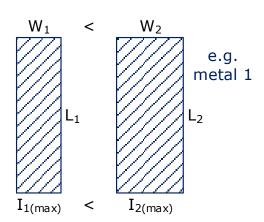


Layout Steps



Routing:

- Connecting the instances/sub-blocks with different metal layers
- Routing introduces parasitics, which may deteriorate the performance
 - Parasitic resistances, capacitances or even inductances
 - E.g.: The parallel placement of interconnects raises a crosstalk of signals
- To minimize the effect of electromigration, the foundry specifies maximal currents for metal interconnects:
 - Simplified rule for the lab:
 - Metal: $I_{max} = 1 \text{ mA/}\mu\text{m} (W = 1 \mu\text{m} \rightarrow 1 \text{ mA})$
 - Vias: $I_{max} = 0.2 \text{ mA/via} (1 \text{ Via} \rightarrow 0.2 \text{ mA})$
 - Example: For $I = 300 \mu A$ use at least W = 300 nm and 2 Vias in parallel.
 - Rule of thumb: Add as many contacts/vias as the design allows to achieve reliability







Multisegment resistors:

Can be used to create more compact layouts

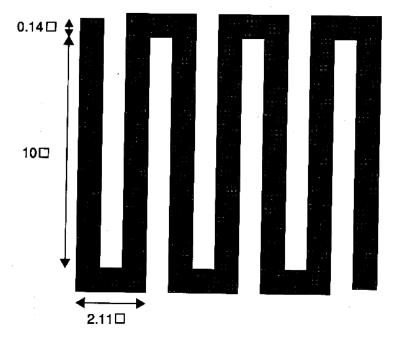
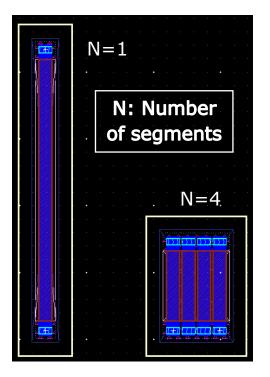


Fig. 2.23 A typical layout for an integrated resistor.







Multifinger MOSFETs:

- Can be used to create more compact layouts
- Reduce the series resistances

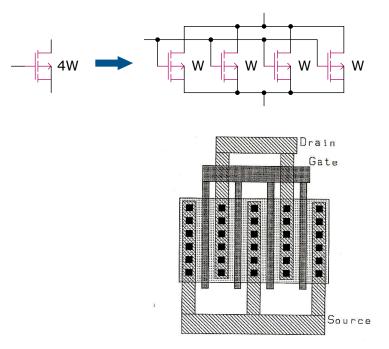
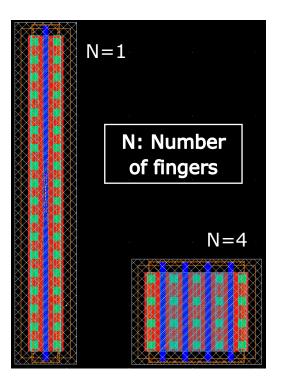


Figure 5.16 Layout of a large (width) MOSFET.







Interdigitated layout:

- Area savings
- Effects of process variation and mismatch can be reduced
- Applicable for current mirrors, resistive networks,...

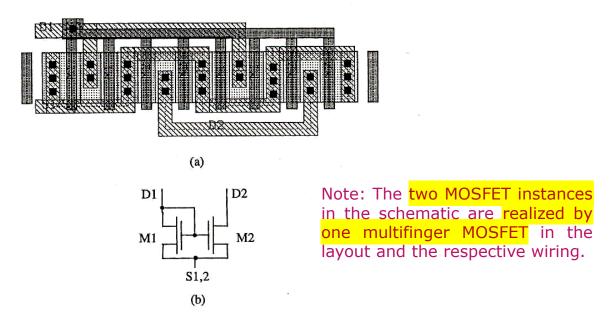


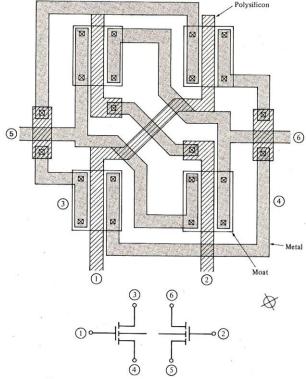
Figure 20.18 (a) Layout of a simple current mirror using interdigitation and (b) equivalent circuit.

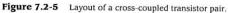


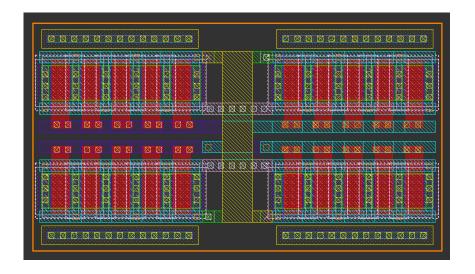


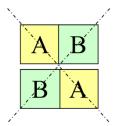
Common centroid layout:

- Effects of process variation and mismatch can be reduced
- Applicable for differential pairs, single transistors, passives,...









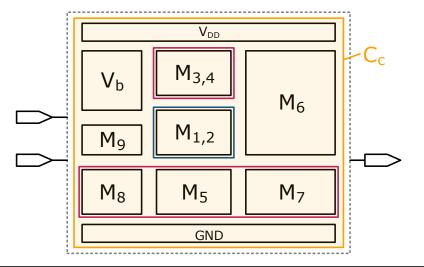
Note: The array should be symmetrical around both the x and y-axis.



Example: OPAMP Layout Techniques



- Interdigitated layout possible for the active load $(M_{3,4})$ and the biasing current mirror $(M_8, M_5 \text{ and } M_7)$
- Common centroid layout possible for the differential pair (M_{1,2})
 - Don't split W to pieces smaller than 3 μm!
- The coupling capacitor (C_c) can be placed next to the OPAMP (in some technologies even on top of the whole circuit to save area)
 - On top not possible in umc65/l/



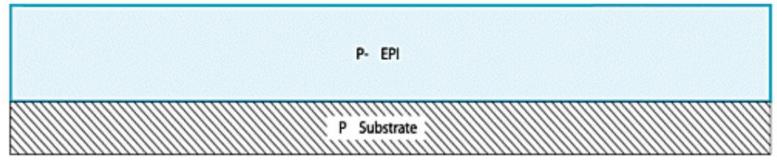
Again, it is up to you, if you want to implement specific techniques in the layout. The floorplan for your OPAMP layout can also differ from the example on the left!





Base Material: p-doped substrate

- Nmos: directly implemented on p substrate
- Pmos: require additional n-well

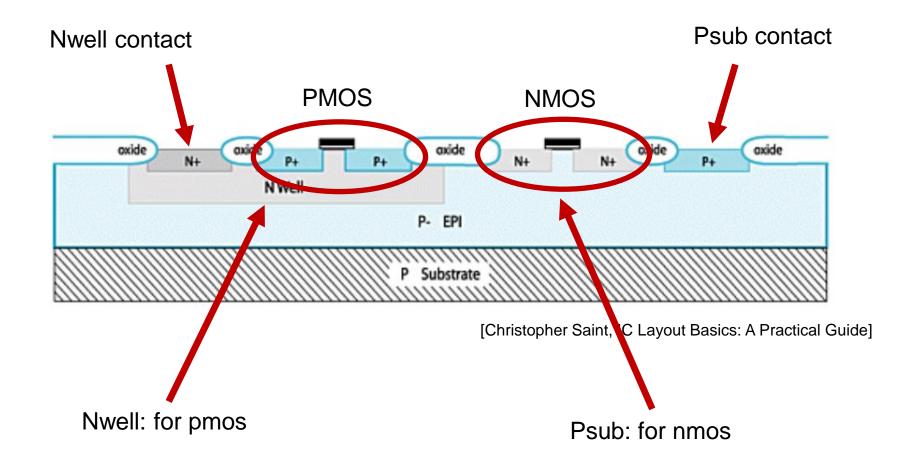


[Christopher Saint, IC Layout Basics: A Practical Guide]

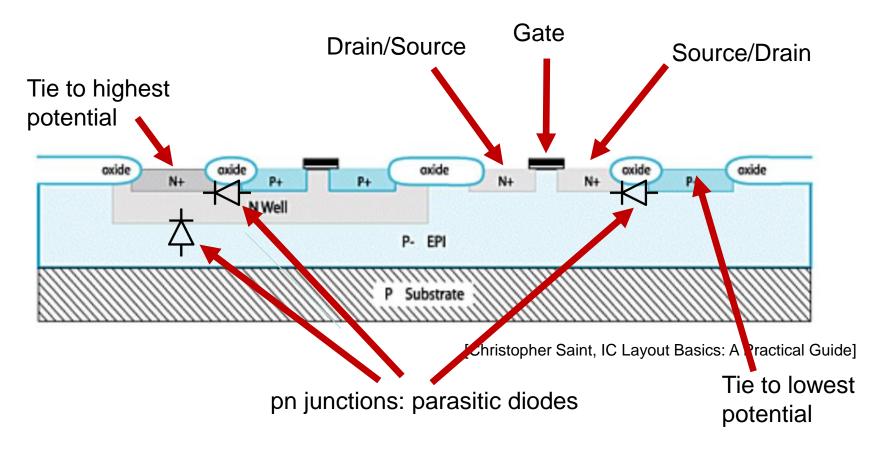
- the p-doped substrate is a poorly conductive
 - Provide enough substrate contacts for good conectivity
 - All substrate contacts must be the same electrical net







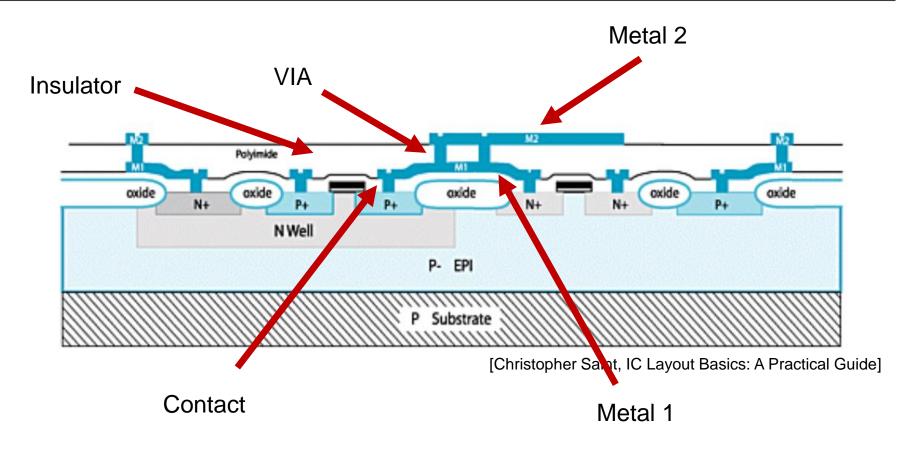




• pn junctions act as parasitic diode. Make sure to always reverse bias these!







 Establish the circuitry by connecting the semicondutor elements using contacts, VIA's and Metal





- UMC offers parameterized cells for all the components/devices present in their 65 nm foundry design kit.
- These PCELLs allow the user to create schematics and layouts at a higher level of abstraction.
- For the layout you do not have to worry about the internal structure of the transistors, resistors, etc., you simply have to place them.

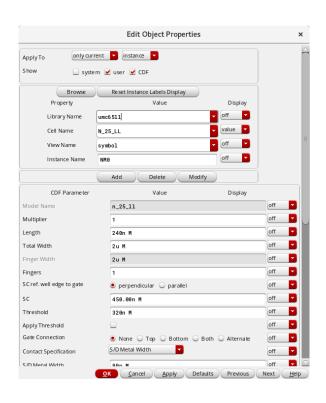


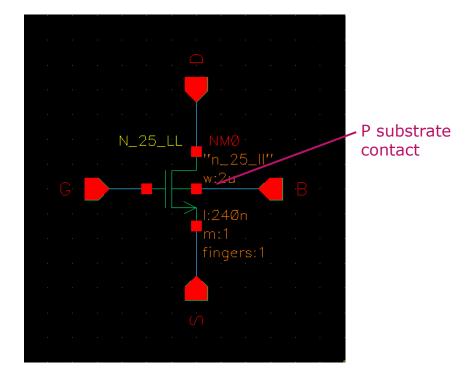


NMOS in schematic:

Cell: N_25_//

View: symbol









NMOS in layout:

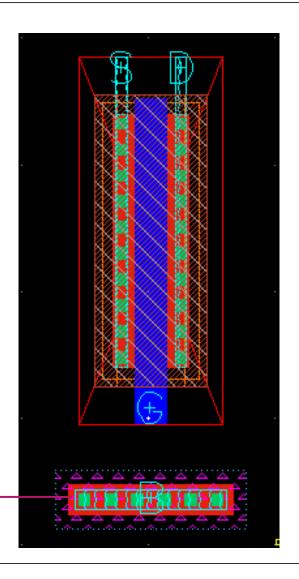
• Cell: *N_25_LL*

View: layout

Note: Depending on the length and width as well as the number of fingers, your transistor will appear differently.

Note: The device is symmetric. Source and Drain can be interchanged and are defined by your connections.

psub contact (M1_PSUB via)



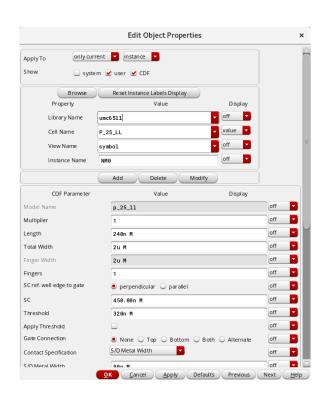


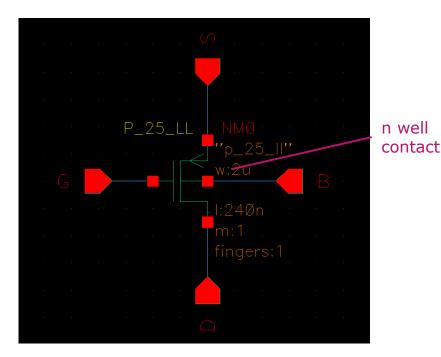


PMOS in schematic:

Cell: P_25_//

View: symbol









PMOS in layout:

Cell: P_25_LL

View: layout

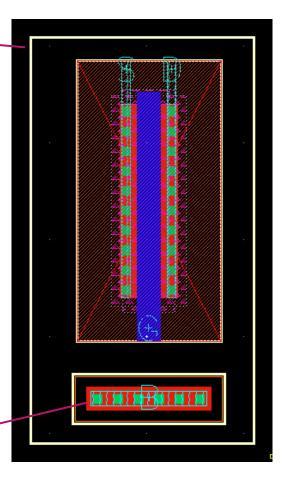
nwell outline (Layer NWEL)
Enclosed area is a nwell

Note: Depending on the length and width as well as the number of fingers, your transistor will appear differently.

Note: The device is symmetric. Source and Drain can be interchanged and are defined by your connections.

Note: The enclosed area of the nwell outline will be an nwell. The nwell contact must be in the same well as the transistor itself. To save area, you can place multiple devices inside the same nwell.

nwell contact (M1_NWEL via)



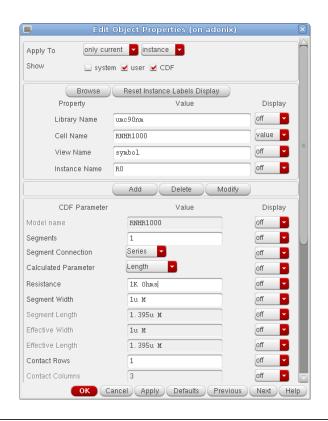


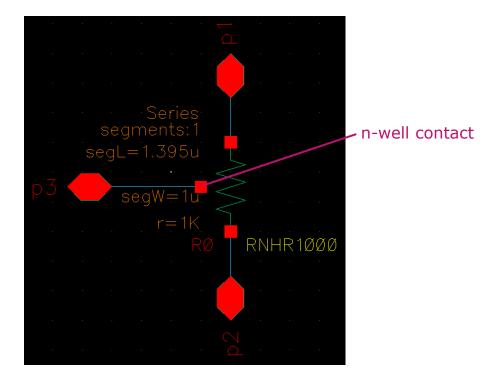


Resistor in schematic:

Cell: RNHR_LL (high resistance poly resistor)

View: symbol





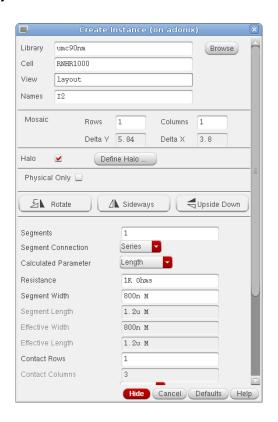




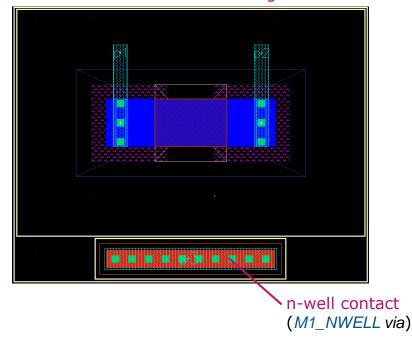
Resistor in layout:

Cell: RNHR_LL (high resistance poly resistor)

View: layout



Note: Your layout of the resistor might look different than shown here. It varies with the chosen number of segments.







Capacitor in schematic:

Option 1:

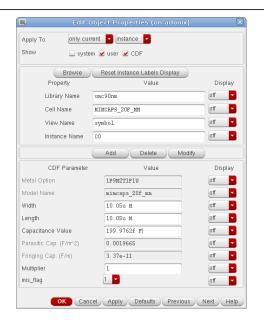
Cell: MIMCAPS_20F_MM(metal-insulator-metal capacitor).

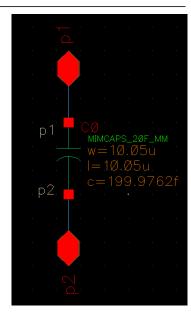
View: symbol

Option 2:

Cell: MOMCAPS_AS_MMKF (metal-insulator-metal capacitor).

View: symbol





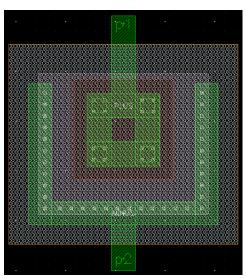




Capacitor in layout:

- Option 1:
 - Cell: MIMCAPS_20F_MM(metal-insulator-metal capacitor).
 - > View: layout
- Option 2:
 - Cell: MOMCAPS_AS_MMKF (metal-oxide-metal capacitor).
 - ➤ View: *layout*







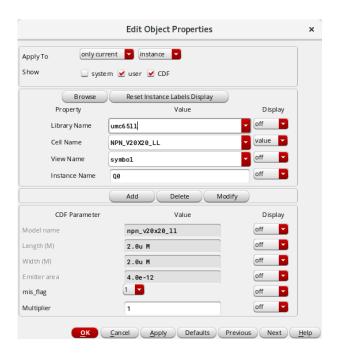


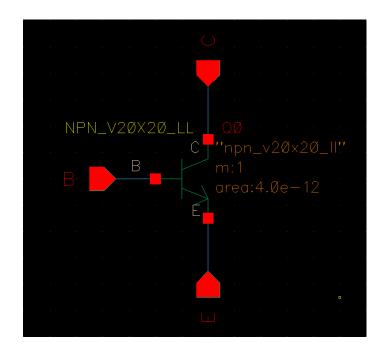
BJT in schematic: (BGR Task Only)

Cell: NPN_V20x20_LL (as example)

equivalent: *V32x32*, *V50x50*, *V100x100*

View: symbol





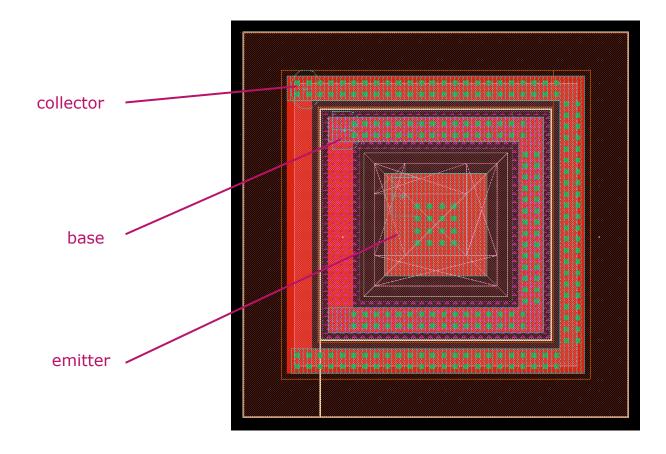




BJT in layout: (BGR Task Only)

Cell: NPN_V20x20_LL (as example)

View: layout





Additional Hints



- The M1_NWEL (local n-well) and M1_PSUB (global p-substrate) contacts/vias should always be placed close to the corresponding device(s).
- Remember: For this lab the NWEL contact should always be connected to the highest and the PSUB contact to the lowest potential of the circuit, i.e., vdd and gnd!
- You can place more than one of the resistors/p-transistors in a common n-well, but consider the hints above.



Summary



- Matching
 - Between multiple instances of components, differential pairs, resistive dividers etc.
 - Between multiple instances of same circuit block
 - Common-centroid, multi-fingering, interdigitation, multi-segmenting
- Current Densities
 - Interconnects, Metal paths etc
- Dimensioning & Area
 - Keep area requirement in mind when dimensioning components
 - For example, which width should be chosen for the resistor to keep area requirement minimum
- Compact Layout
 - Placement
 - Routing
 - Less vacant area
 - Remember, the larger the area, the higher the fabrication costs
- Reference Book → The Art of Analog Layout by Hastings

